Applicant Initiated Interview Request Form -- faxed to: 571. 273. 2639 (1 pp.)

In re the Application of

Takayuki TAKAHAGI et al.

Group Art Unit:

1793

Application No.: 10/576,976

Examiner:

P. PARVINI

Filed: July 17, 2006

Docket No.:

127804

For:

LIQUID COMPOSITION, MANUFACTURING METHOD THEREOF, LOW DIELECTRIC CONSTANT FILMS, ABRASIVE MATERIALS, AND ELECTRONIC COMPONENTS

Tentative Participants: (1) Chris Brown		(2)	Examiner Parvini			
(3)		(4)				
Confirmed Date of Inter	view: 8/23/10		Proposed Time:	10 AM	(AM	I/ PM)
Type of Interview Reque (1) ☑ Telephonic	sted: (2) Personal		(3) 🔲 Video Confe	rence		
Exhibit To Be Shown or Demonstrated: If yes, provide brief description:		YES		⊠ NO		
Issues To Be Discussed						
Issues (Rej., Obj., etc)	Claims/ Fig. #s		Prior Art	Discussed	Agreed	Not Agreed
(1) 35 U.S.C. §103(a)	1	<u></u> _	Takashina			
(2)						
(3)						
Continuation Sheet Attached						
Brief Description of Arguments to be Presented:						
Follow-up discussion focused on claim 1 language "a dielectric film forming liquid composition" previously suggested by Patent Office, and how the claim 1 language distinguishes over Takashina.						
An interview was conducted on the above-identified application on						
<u>NOTE</u> : This form should be comp	leted by applicant and s	ubmitted	i to the examiner in a	dvance of the inter	view (see MP	EP § 713.01).
This application will not b Therefore, applicant is ad	e delayed from issue bed vised to file a statement o	ause of a	applicant's failure to s ince of this interview (submit a written re (37 CFR 1.133(b) s	ecord of this i is soon as pos	nterview. sible.
Christopher	I W. Grow	w-				
(Applicant/Applicant's Representative Signature) (Examiner/SPE Signature)						